

Amendments to the Specification

Please amend the title as follows:

~~PVD Targets Comprising Copper in Ternary or Higher Order Mixtures and Methods of Forming Copper-Containing PVD Targets and Methods for Their Manufacture~~

At page 1, prior to the Field of the Invention section, please enter the following new paragraph.

RELATED PATENT DATA

This application claims priority to Patent Cooperation Treaty application Serial No. PCT/US2004/027090, which was filed August 20, 2004, and which claims priority to U.S. Provisional Application Serial No. 60/497,149, which was filed August 21, 2003.